

FIG. 1

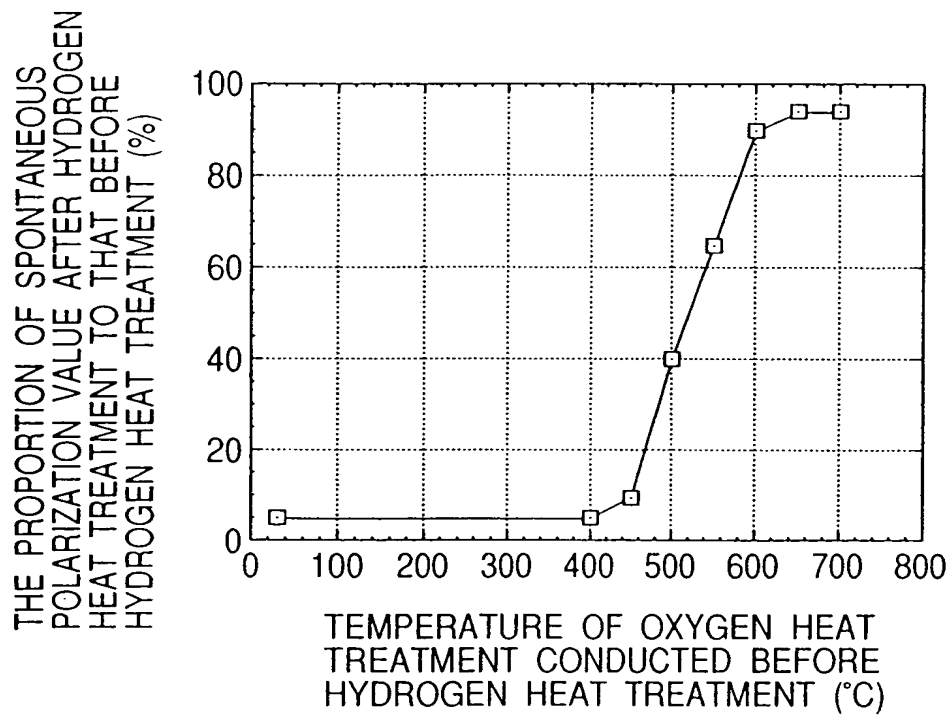


FIG. 2

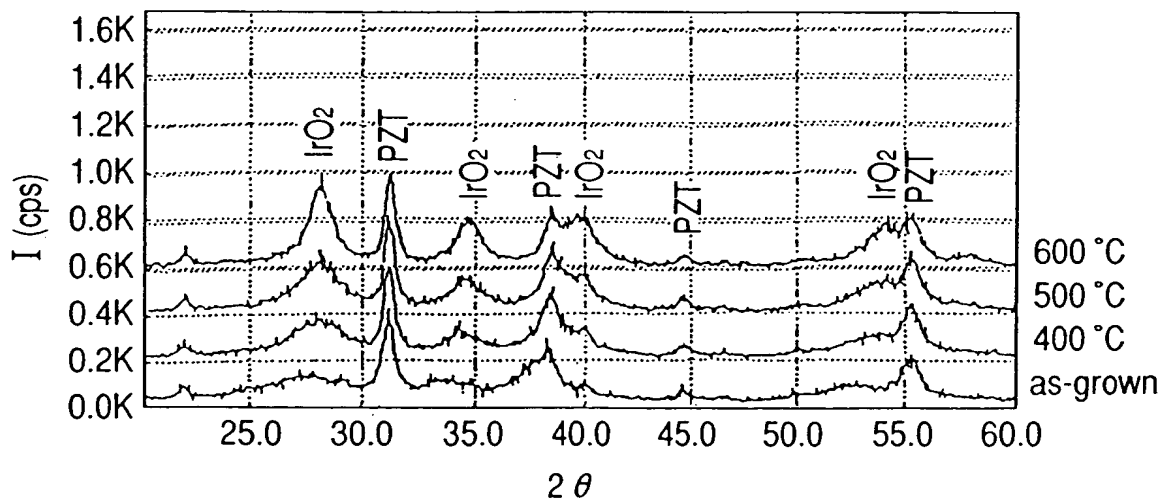


FIG. 3

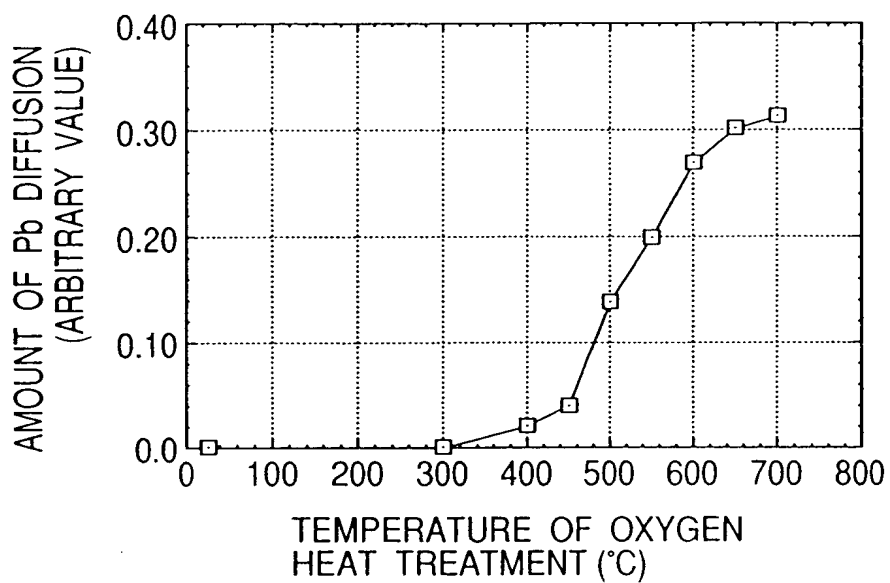


FIG. 4

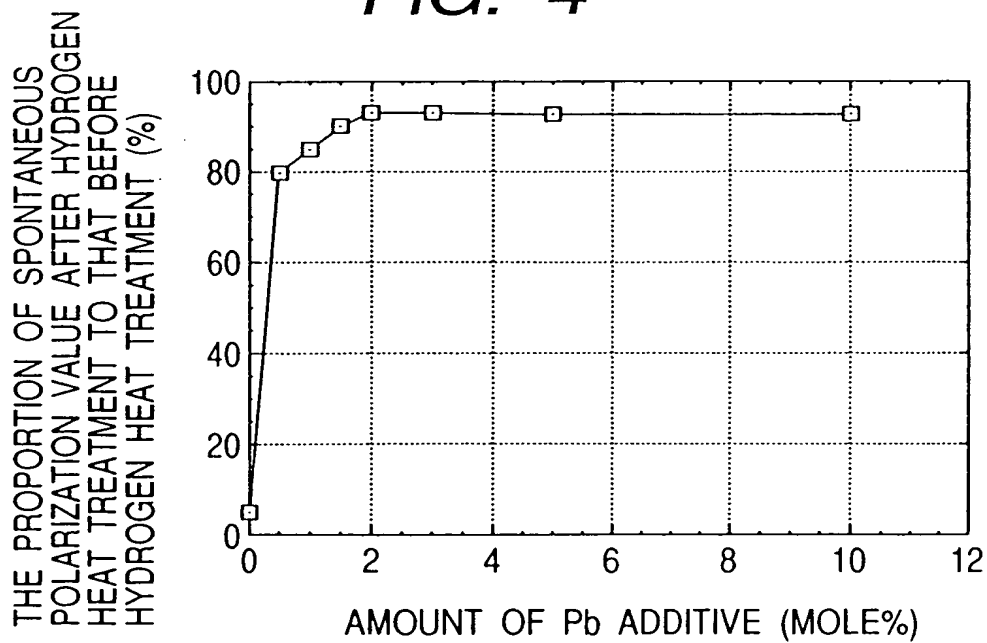


FIG. 5

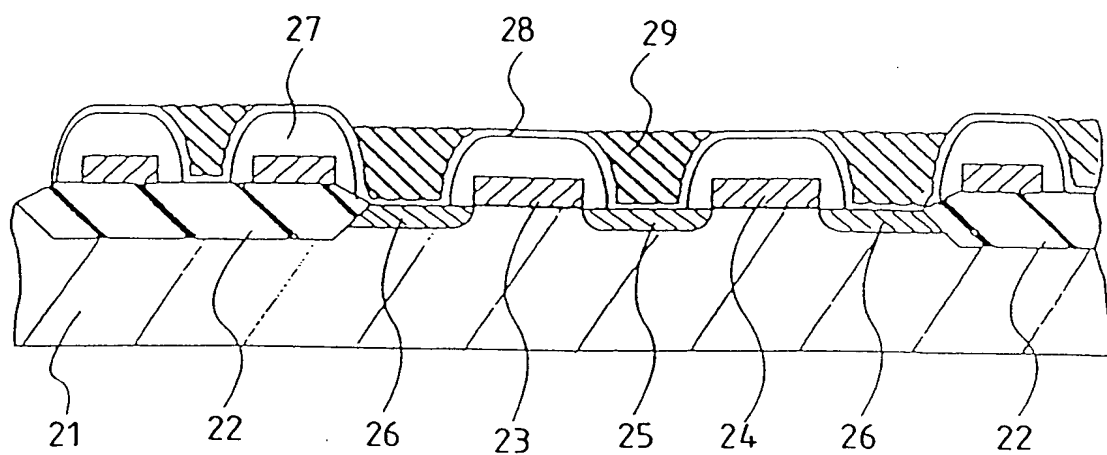


FIG. 6

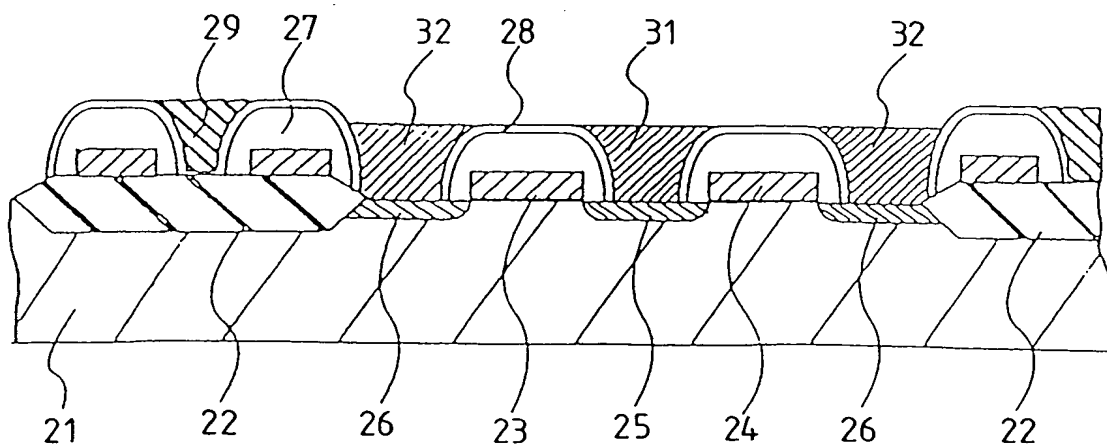


FIG. 7

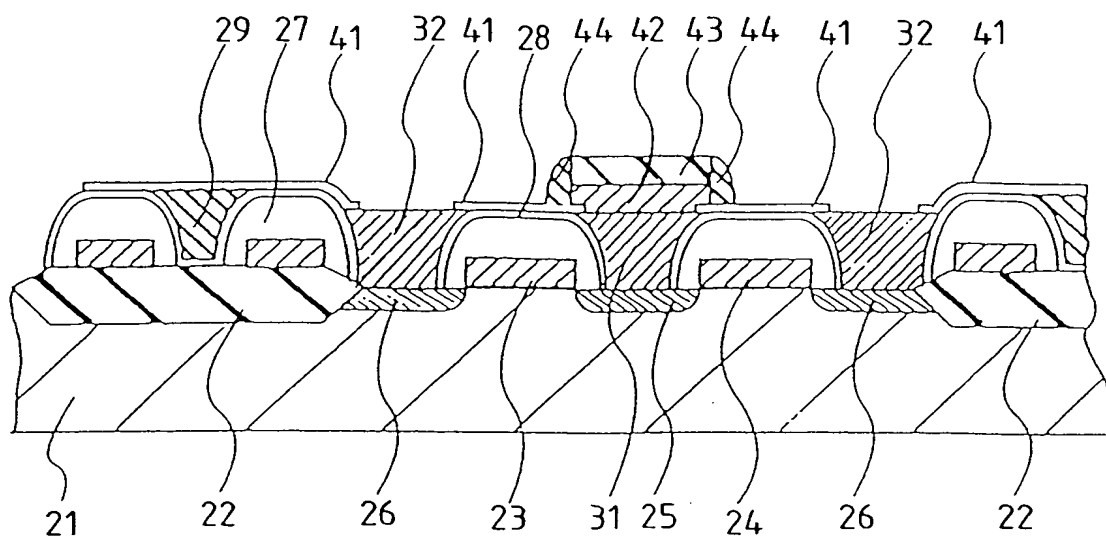


FIG. 8

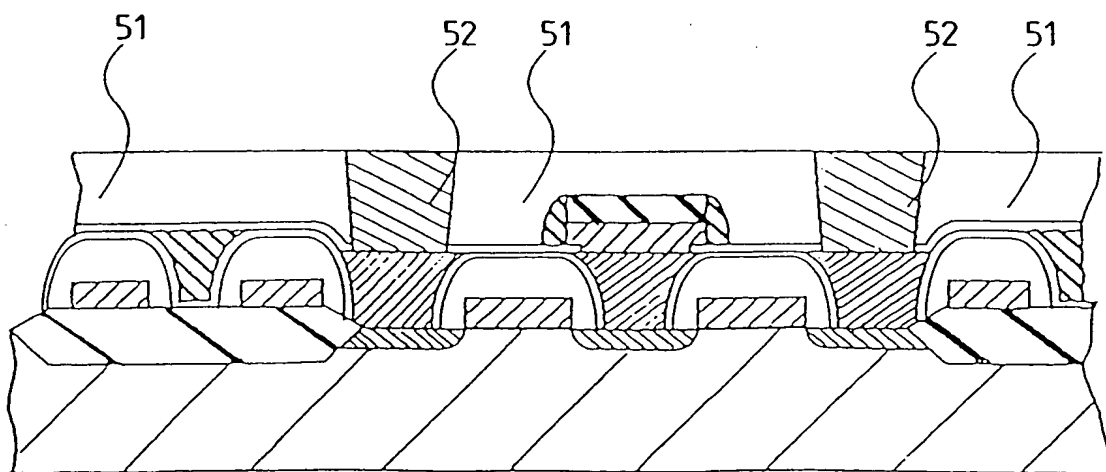


FIG. 9

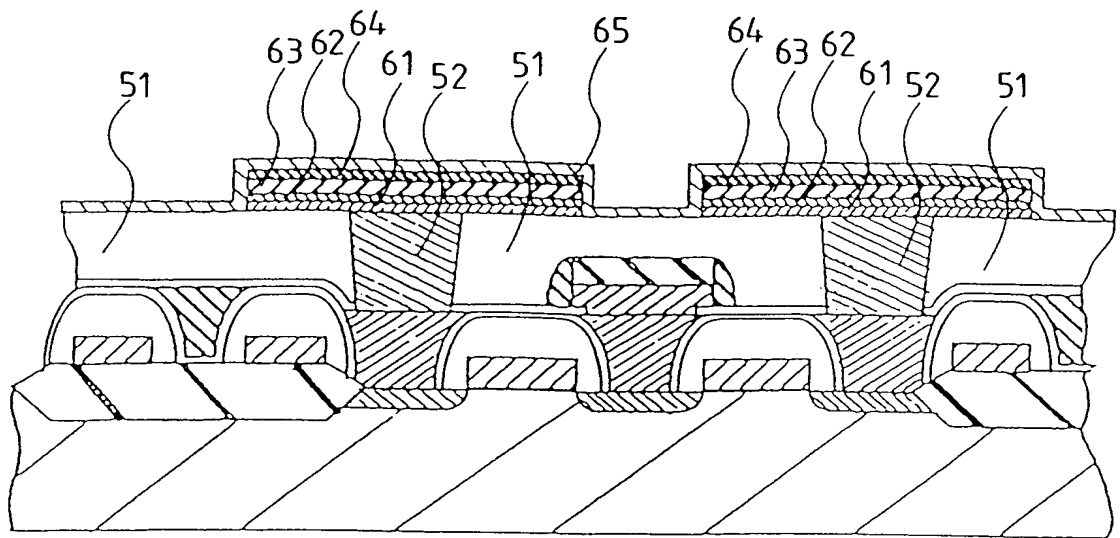
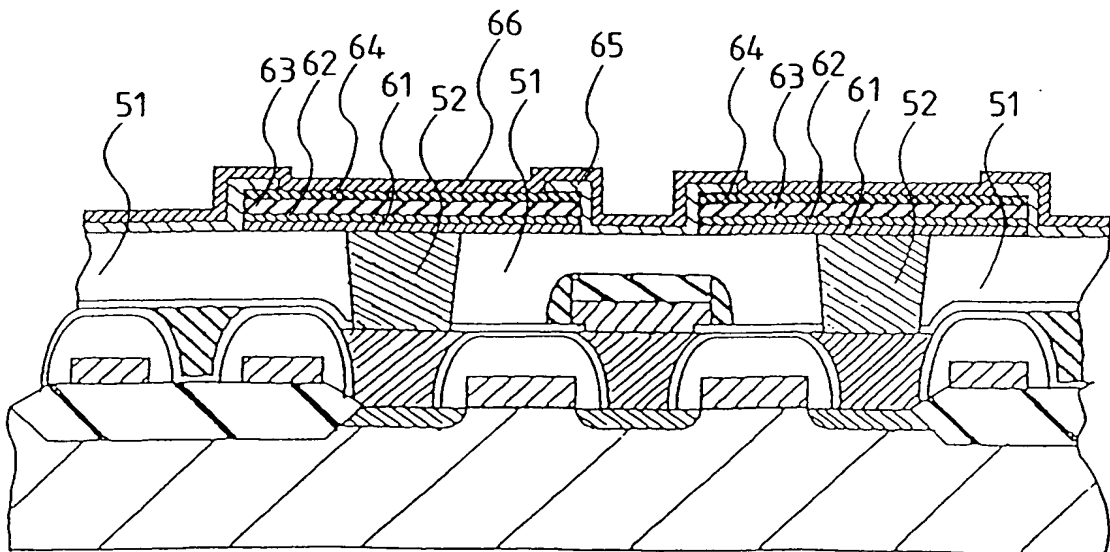


FIG. 10



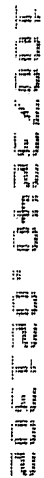
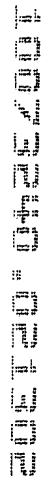
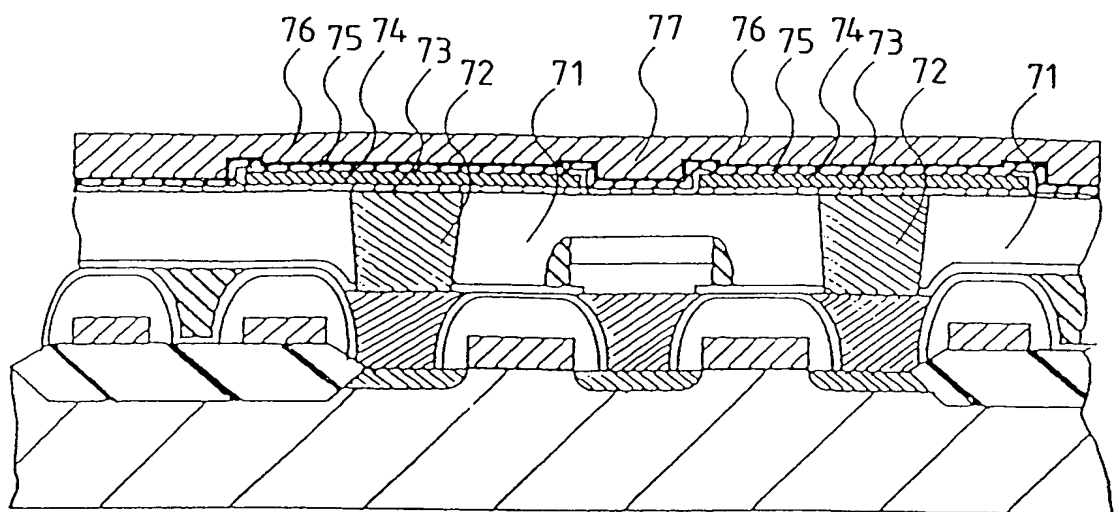
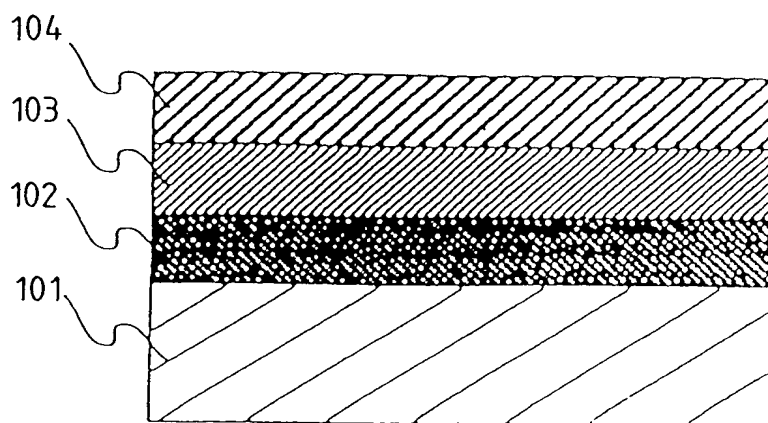
[illegible][illegible]

FIG. 13



*FIG. 14*



104: PLATINUM LAYER WITH Pb ADDITIVE  
(TOP ELECTRODE)

103: FERROELECTRIC THIN FILM

102: BOTTOM ELECTRODE

101: DEVICE LAYER INCLUDING TRANSISTORS  
(OR METAL SUPPORT)



FIG. 15

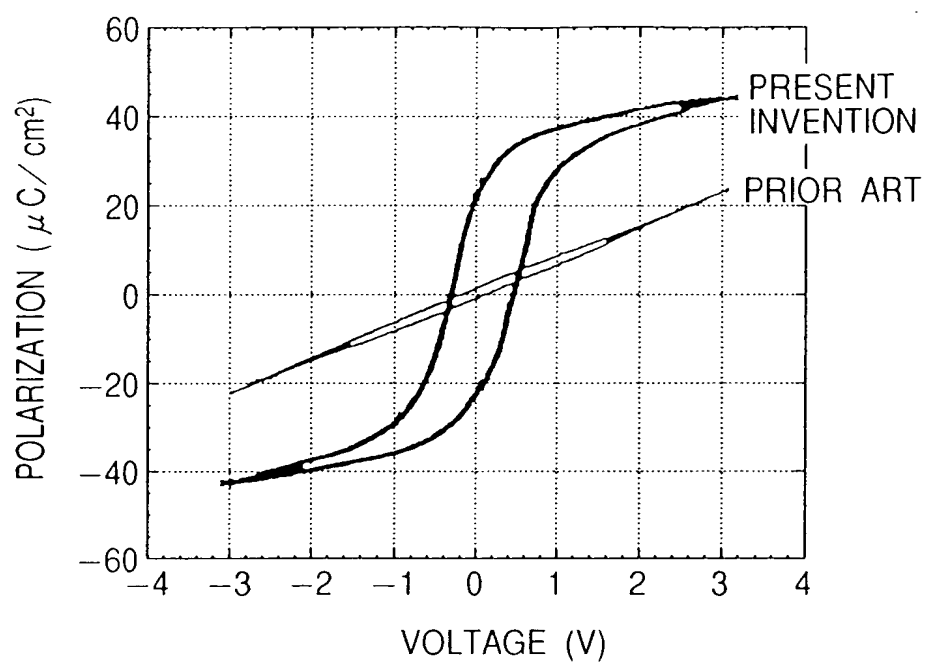


FIG. 16

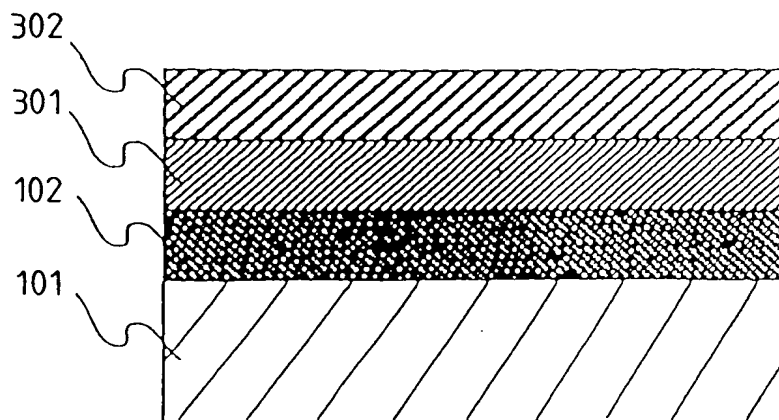


FIG. 17

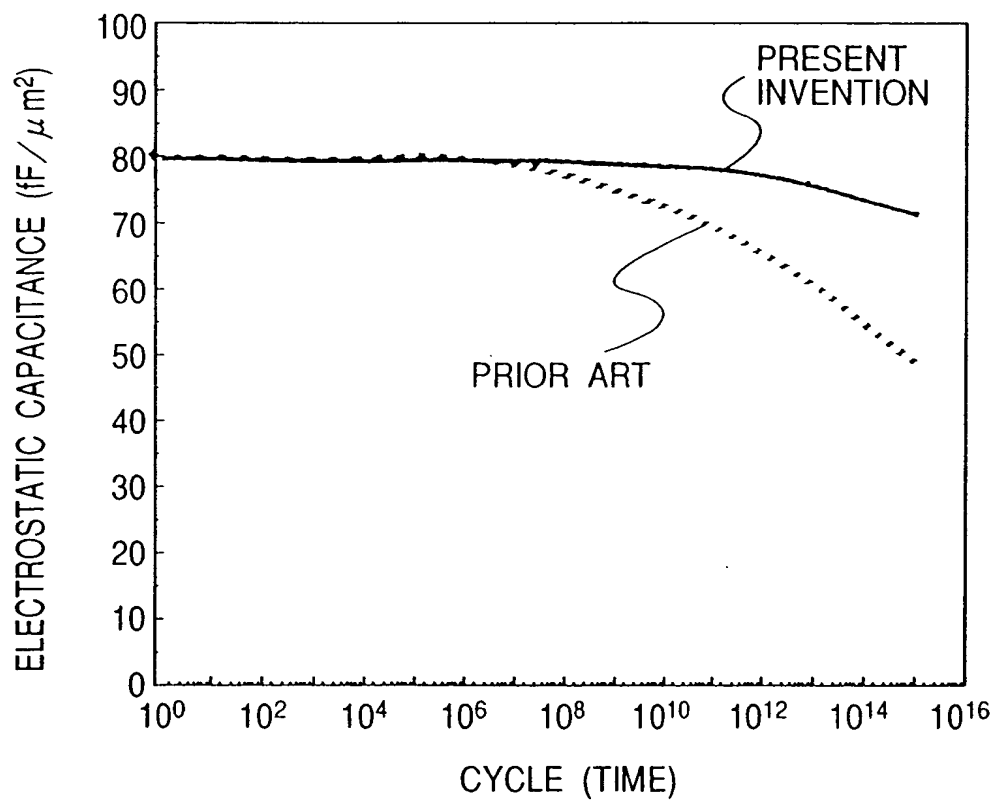
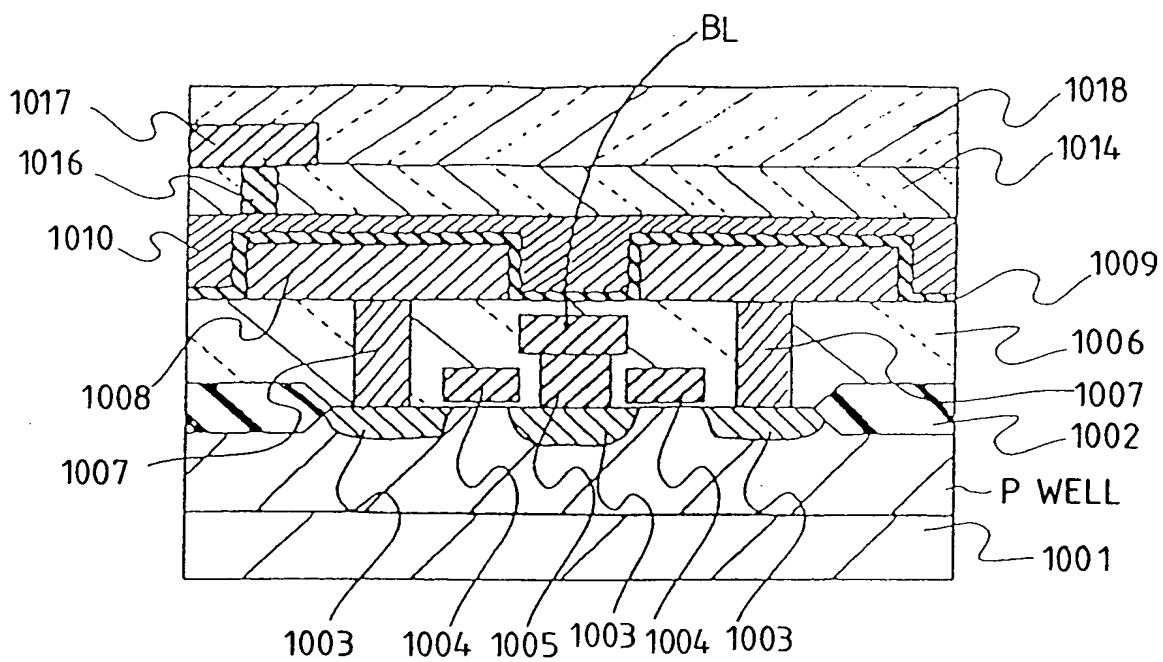


FIG. 18



1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31	32	33	34	35	36	37	38	39	40	41	42	43	44	45	46	47	48	49	50	51	52	53	54	55	56	57	58	59	60	61	62	63	64	65	66	67	68	69	70	71	72	73	74	75	76	77	78	79	80	81	82	83	84	85	86	87	88	89	90	91	92	93	94	95	96	97	98	99	100
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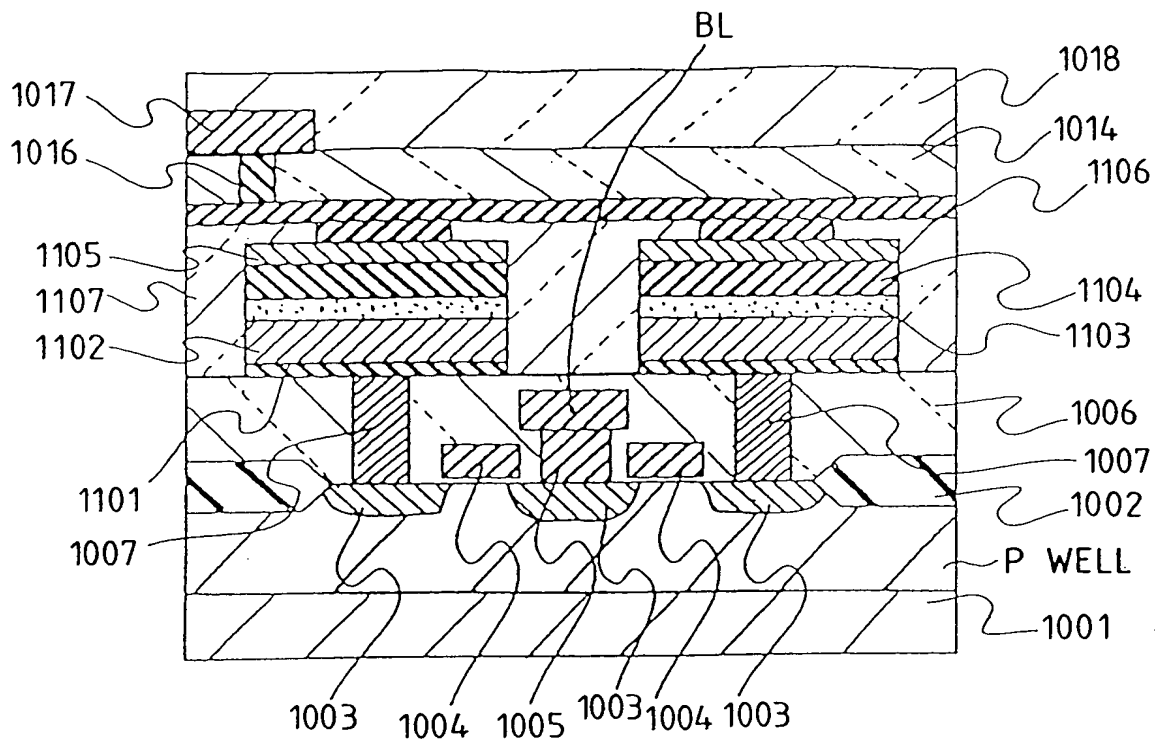


FIG. 20

